

35000/02 PTO
10/006967
12/05/00

BEST AVAILABLE

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

44

APPL NUM 10006967	FILING DATE 12/05/2001	CLASS 438	SUBCLASS 460	GAU 2842	EXAMINER 2822
**APPLICANTS: Felton Lawrence; Luo Jing; <i>u - Picaudet</i>					
**CONTINUING DATA VERIFIED: THIS APPLN CLAIMS BENEFIT OF 60/251,287 12/05/2000 AND CLAIMS BENEFIT OF 60/251,288 12/05/2000 <i>W</i>					
** FOREIGN APPLICATIONS VERIFIED: <i>Z</i>					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO 5721.1	
Verified and Acknowledged Examiners's initials <i>Z</i>					
TITLE : Method and device for protecting micro electromechanical systems structures during dicing of a wafer					

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-04)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Total Claims	
		Print Claim for O.G.	
		Sheets Drwg.	
		Figs. Drwg.	
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner	
		Application Examiner	
		PREPARED FOR ISSUE	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)